OIPE MAGNITURE STREET

Customer No. 22,852 Attorney Docket No. 02887.0259

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Junji SUGAMOTO et al.	
Application No. 10/706,090 Filed: November 13, 2003	Group Art Unit: 2891 Examiner: Smith, Bradley
For: SEMICONDUCTOR WAFER TREATMENT METHOD, SEMICONDUCTOR WAFER INSPECTION METHOD, SEMICONDUCTOR DEVICE DEVELOPMENT METHOD AND SEMICONDUCTOR WAFER TREATMENT APPARATUS)) Confirmation No.: 7292) Output Output

Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

PETITION FOR EXTENSION OF TIME

Applicant hereby petitions for a one month extension of time to reply to the Office Action mailed January 25, 2007. A fee of \$120.00 is enclosed.

Please grant any additional extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER, L.L.P.

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Dated: May 23, 2007

Selah C. Park

Reg. No. 57,127